Se	arch N	otes	

Application/Control No.	Applicant(s)/Patent under Reexamination	•••••• ••
09/917,961	BEAN ET AL.	
Examiner	Art Unit	
Dennis Rosario	2621	

SEARCHED			
Class	Subclass	Date	Examiner
382	313	6/22/05	DR
348	296	11/22/05	012
	367)a	16
396	471	li 	11
·	(457)	(4/7/00))+/16/05	GK.
382	211	417106	DIS
348	740	10	14
359	259	K	ņ

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
East Search (polated) IEEE Search	6/15/05 (1/29/5) (1/23/05)	(DR)	
Consulted Ngoc Yen and Heather Long about claims I and	11/22/05		
IEEE-microshutter - (modulator or shutter or	-11128105 (4171 <i>0</i> 6)		
exposure) near pattern and camera) -	·		